

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Michihiko TAKASE

Mail Stop: PCT

Serial No. NEW

Attorney Docket No. 2005\_0643A

Filed April 26, 2005

METHOD FOR MANUFACTURING PLASMA DISPLAY PANEL [Corresponding to PCT/JP2004/010365 Filed July 14, 2004]

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT **ACCOUNT NO. 23-0975** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicant requests consideration of the references listed on attached form PTO-1449 and any additional information 9

Consid	icialion o	The references listed on attached form 1 10-1447 and any additional information				
identii	fied belov	w in paragraph 3. A legible copy of each reference listed on the Form PTO-144				
is encl	losed, exc	cept a copy is not provided for:				
	[]	each U.S. Patent and U.S. Patent application publication;				
	D	each reference previously cited in the international application PCT/; and/or				
	0	each reference previously cited in prior parent application Serial No.				
1a.	[X] This Information Disclosure Statement is submitted:					
	within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or					
	before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,					
	and thu	s no-certification and/or-fee is required,				

1b. [] This Information Disclosure Statement is submitted

after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:

- (1) [] the certification of paragraph 2 below is provided, or
- (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.
- 1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

- 2. It is hereby certified
  - a. [] that each item of information contained in this Information Disclosure

    Statement was first cited in any communication from a foreign patent office in a

    counterpart foreign application not more than three months prior to the filing of
    the Statement, or
  - b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.
- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.
- 4. For each non-English language reference listed on the attached form PTO-1449, reference is made to:
  - a. [X] a full or partial English language translation submitted herewith,

- b. [X] an International Search Report (in the English language) submitted herewith,
- c. [] the concise explanation contained in the specification of the present application at page,
- d. [X] the concise explanation set forth in the attached English language abstract,
- e. [] the concise explanation set forth below or on a separate sheet attached to the reference:
- 5. [X] An International Search Report citing one or more of the references is enclosed.

Respectfully submitted,

Michihiko TAKASE

By

rey K. Filipek

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JRF/fs

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April 26, 2005

Sheet 1 of 1		· A · ,	INFORMA	TION DISCLOS	URE STATEMENT	JC13 Bec'd	PCT/PTO	26 API	2005	
FORM PTO 1449 (modified)			APPLICANT Michihiko TAKASE  ATTO DISCLOSURE STATEMENT C13 Bec'd PCT/PTO 26 APR 2005  AL NO 10/532672  APPLICANT Michihiko TAKASE							
PATENT AND TRADEMARK OFFICE										
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  Date Submitted to PTO: April 26, 2005					FILING DATE GROUP April 26, 2005					
			U.	S. PATENT DOC						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	N	IAME	CLASS	SUBCLASS FILING DATE IF APPROPRIATE			
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	AJ	2001-243886	9-7-01	Ja	apan			abstract		
	AK	2003-31136	1-31-03	Ja	apan			abstract		
	AL	01/59173	8-16-01	V	WO			abstract		
	AM	2000-129428	5-9-00	Ja	apan			abstract		
	AN	2002-56773	2-22-02	Ja	apan			abstract		
		OTHER	DOCUMENT(S) (I	Including Author,	Title, Date, Pertin	ent Pages, Etc.)				
	AO	Shigeo KASAHARA, "Chapter 6: MgO layer forming technology", 2001 FPD Technology Outlook, Part 2: PDP, <part 2,="" 3="" volume="">, pages 598-600 along with English translation</part>								
	AP									
	AQ									
EXAMINER /E	EXAMINER /Elizabeth Burkhart/			DATE CONSIDERED 03/05/2008						